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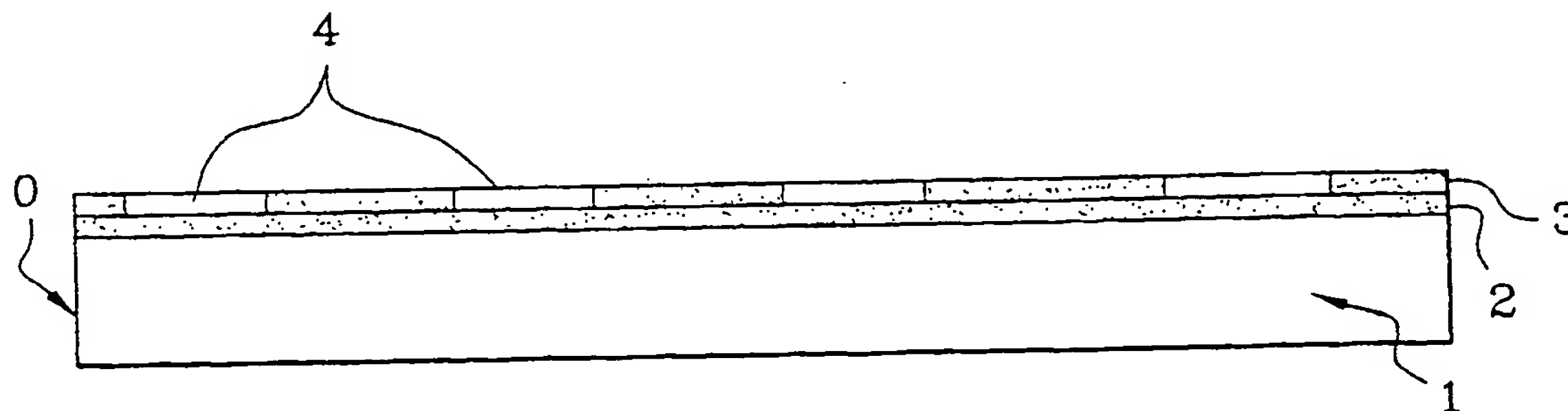
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(54) Title: **PROCESS TO ALLOW ELECTRICAL AND MECHANICAL CONNECTION OF AN ELECTRICAL DEVICE WITH A FACE EQUIPPED WITH CONTACT PADS**



(57) Abstract: A method of manufacturing an electrical device that is electrically and mechanically connectable to another electrical device, the electrical device having a face equipped with contact pads, the method being characterised in that it includes: - a layer-application step in which an adhesive layer is applied on the face equipped with contact pads, the adhesive layer being composed of a substance with adhesive properties; - an opening-creation step in which an opening is created through the adhesive layer at the level of a contact pad; - an opening-filling step in which the opening is filled with a conductive material so that the opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening.

Process to allow electrical and mechanical connection of an electrical device with a face equipped with contact pads

Invention field

This invention concerns the electrical and mechanical connection of an electrical device with another electrical device. Both could be for example a
5 wafer, an integrated circuit or even just a component. This invention applies especially to the field of integrated circuits protection and in particular in the field of memory cards.

Previous art

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A connection process is based on the use of a film called ACF (Anisotropic Conductor Film). This type of film contains conducting elements extending through the film thickness. According to a first stage, the film is made separately onto a neutral support. According to a second stage, the film is
15 finely recovered using sub-engraving. According to a third stage, the film is pasted with glue on each face to apply it then onto a first component. A last stage consists in connecting a second component onto the part of the film that is not yet covered. Finally, both components are fixed mechanically through the glue pasted on both faces of the film, and electrically using the
20 metal elements enclosed in the film.

US 6,256,874 describes a method for connecting two conductive layers in an electronic circuit package comprising the steps of forming dentrites on selected regions of a first conductive layer, forming dentrites on selected
25 regions of a second conductive layer. Dentrites are formed by means of a photoresist material to the area of a first surface metal and then expose and

develop the resist by photolithographic techniques to provide an exposed area on which dendrites are to be formed. The photoresist is then removed. The method further comprises the step of applying an epoxy adhesive material over the first conductive layer, and compressively attaching the second conductive layer to the first conductive layer such that the dendrites on the first conductive layer contact the dendrites on the second conductive layer.

Description of the invention

An object of the invention is to reduce the costs.

According to one aspect of the invention a method of manufacturing an electrical device that is electrically and mechanically connectable to another electrical device, the electrical device having a face equipped with contact pads, the method being characterised in that it includes:

- a layer-application step in which an adhesive layer is applied on the face equipped with contact pads, the adhesive layer being composed of a substance with adhesive properties;
- an opening-creation step in which an opening is created through the adhesive layer at the level of a contact pad;
- an opening-filing step in which the opening is filled with a conductive material so that the opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening.

The adhesive layer is, as it were, used as a mould to form the conductive path. Consequently there is no need for a specific photoresist layer as in US 6,256,874. The invention thus allows a reduction of the costs.

Drawings

This invention shall be better grasped after reading the following non-
5 limiting description, written by reference to the attached drawings, where:

- figure 1 shows as a cross-section, a plate which is a starting point for the invention process;
- figure 2 shows as a cross-section, a fixing organic layer applied to the
10 plate according to a first stage in the process subject of the invention;
- figure 3 shows as a cross-section, a fixing organic layer that has been structured according to a second stage in the process subject of the invention;
- figure 4 shows the stage in the process according to the invention in
15 which the fixing layer is equipped with small metal sticks;
- figure 5 shows, as a horizontal projection and as a cross-section, part of a plate;
- figure 6 shows the beginning of the fixing stage according to the invention process;
- 20 - figure 7 shows, as a cross-section, the plates after the stage of fixing by thermo-compression;
- figure 8 shows, as a cross-section, the first-plate tapering.

Modes of embodiment of this invention

25

Figure 1 shows a starting point in the process according to the invention. It shows a plate 0 including a silicium chip 1 on which are arranged circuits 2. A passivation layer 3 is superimposed on the layer including circuits 2. In this passivation layer 3 there are contact pads 4 inserted with the purpose to
30 arrange interconnection with additional circuit.

Figure 2 shows the first stage in the process, actually a stage of laying down an organic layer 5 with sticking characteristics. This organic layer is superimposed on the passivation layer 3 including contact pads 4. This organic layer is for instance laid in the form of a solution obtained by centrifuging.

After a drying stage, and as shown by figure 3, organic matter 5 is removed partially or completely, and this in particular at the level of the contact pads 4. This matter removal may be achieved for instance by etching. If the organic matter is photosensitive, it may be also exposed, after applying a masker, to rays and in particular to UV rays. The parts of organic matter exposed are finally dissolved using a chemical bath. The organic layer 5 so modified is said to be formed into a structure.

Figure 4 shows the following stage which is a stage of growth for small metal sticks 7 in the areas where the organic matter has been removed. This metal stick growth is achieved for instance in chemical baths using electroless or electrochemistry. The small metal sticks 7 are directed preferably perpendicular to the contact pad surface 4 and are insulated from each other by the organic matter in layer 5. Although figure 4 suggests the existence of small metal sticks 7 at the level of the contact pads 4, this does not exclude the possibility to also grow some in other areas.

The following stage, as shown on figure 6, is a stage to align a second plate 0' of the same type as plate 0 on the first plate 0 so that the contact pads 4 and 4' face each other. This second plate may include circuits 2' necessary for the operation of circuits 2.

In a later stage, as described in figure 7, both plates 0 and 0' are fixed, for example, using thermo-compression. Ultrasound techniques may also be used advantageously.

- 5 Plate 0' includes media 8 so as to allow the electrical contacts 4 to exit to the outside by means, for instance, of the wiring cable 9 as can be seen on figure 7.

Figure 8 shows that it is possible to proceed next to the plate 0 tapering at
10 the level of its lower face 1" in order, for instance, to enable a possible slip sheet inserting into a card body or so as to increase the difficulty in separating circuits for safety.

Of course, the description of the invention embodiment as given above is not
15 limiting for the invention which must be understood broadly.

In particular, the subject of this invention may apply not only to the field of mechanical and electrical connections at the level of a component or an integrated circuit, but also at the level of any other electrical device with a
20 face equipped with contact pads. It may be in particular a question of wafers of any size, for example with a diameter of 150 mm and comprising approximately one thousand components.

Regarding the organic layer 5, any material preferably with sticking
25 characteristics, may be used. This may be in particular polyimides, photosensitive resins or thermoplastics. These materials also have the advantage of stimulating the growth of metal compounds.

The use of thermoplastics is interesting since it will be possible to separate without damage the two electrical elements. On the other hand, the
30 polyimides will be used with an advantage whenever it is intended to make

difficult the separation of the two components without physical damage. This is particularly interesting in the field of memory cards regarding physical security.

- 5 The small metal sticks 7 may be more generally metal compounds, for example compounds with nickel, palladium or copper.

Preferably, as can be seen on figure 5, several small metal sticks 7 can be grown per contact area 4, typically about ten. This allows relatively good
10 quality electrical contacts. The metal small sticks diameter is between, for example, 10 and 30 μm .

The metal contact structure (4,7,4') according to this invention avoids what is called contact recovery. This is because on the market wafers, localised oxidation patches often exist on contact pads, that are generally in
15 aluminium. The contact recovery consists in cleaning these contact pads to remove the oxidation so as to have good quality electrical connections. However the contact structure according to this invention (4,7,4'), especially because of the number and the reduced size of the cross-section of small metal sticks 7 in relation to the size of the oxidation patches, enables
20 eliminating this stage called contact recovery.

Let us assume for instance that, at the level of a certain contact pad, there are 25 metal small sticks. Let us assume also that there is an oxidation patch that prevents 10 of these 25 small sticks to be in contact with the contact pad. In this case, there remains 15 metal small sticks in contact and
25 ensuring however a rather good electrical connection between the electrical devices.

In the case, in particular, of fixing by thermo-compression, it is better if the conductive paths 7 shown on figure 7 have a length higher than the organic
30 layer thickness 5, so that when fixing, there is a good interpenetration of

these paths in the metal of the contact pads 4' of the second plate 0'. Generally, these pads are in aluminium and are about 1 μm thick.

Also other modes of embodiment are likely to give results that are particularly interesting.

At the interface fixing level (5,7), several layers of composite materials may be used. An intermediary layer may be used to rearrange the contact areas 4 on the interface (5,7). Further to structuring a first organic layer, metal tracks may be created by deposition. A second structured organic layer may again be used for the growth of metallic compounds.

Several layers analogous to the organic layer 5 may be used in this way, either to create conducting media, or to create metal tracks. The last stage remains the stage of the electrical and mechanical connection with the second electrical device.

Several layers, analogous to the organic layer 5, may also be used to improve the security and the complexity of the interface. A multi-layer may also improve the quality of fixing via a better planishing of the circuit surface or a look for a better chemical reactivity.

After the growth of metal small sticks in the organic layer 5 which acts as the fixing layer, the plate may be divided into smaller electrical entities, for instance integrated circuits or components. These electrical entities may then be mounted using the technique called Flip chip. The material in the organic layer is used as the sticking agent on the support. It is thus possible to get connections in the order of 10 μm instead of the 40 to 60 μm obtained using the flip chip technique. This reduction in the connection size is especially advantageous in the field of high frequencies.

Claims

1. A method of manufacturing an electrical device that is electrically and mechanically connectable to another electrical device, the electrical device having a face equipped with contact pads, the method being
5 characterised in that it includes:
 - a layer-application step in which an adhesive layer is applied on the face equipped with contact pads, the adhesive layer being composed of a substance with adhesive properties;
 - an opening-creation step in which an opening is created through the
10 adhesive layer at the level of a contact pad;
 - an opening-filing step in which the opening is filled with a conductive material so that the opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening.
- 15 2. The method according to claim 1 characterised in that the fixing layer is a polyimide.
3. The method according to claim 1 characterised in that several openings
20 are created through the fixing layer at the level of the contact pad and in that the conductive material is fed into the openings so that each opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening.
- 25 4. A method to electrically and mechanically connect a first electrical device and a second electrical device, each device having a face equipped with contact pads, the method being characterised in that it includes:

- a layer-application step in which an adhesive layer is applied on the face equipped with contact pads of the first electrical device, the adhesive layer being composed of a substance with adhesive properties;
 - an opening-creation step in which an opening is created through the adhesive layer at the level of a contact pad;
 - an opening-filing step in which the opening is filled with a conductive material so that the opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening;
 - a device connection step, in which the said fixing layer is brought into contact with the said face of the second electrical device, with a conductive path making an electrical connection between a contact pad of the first electrical device and a contact pad of the second electrical device.
5. A method to electrically and mechanically connect a first wafer and a second wafer, each wafer having a face equipped with contact pads, the method being characterised in that it includes:
- a layer-application step in which an adhesive layer is applied on the face equipped with contact pads of the first wafer, the adhesive layer being composed of a substance with adhesive properties;
 - an opening-creation step in which an opening is created through the adhesive layer at the level of a contact pad;
 - an opening-filing step in which the opening is filled with a conductive material so that the opening is substantially filled with the conductive material so as to form a conductive path the volume of which is defined by the opening;
 - a device connection step, in which the fixing layer is placed into contact with the said face of the second wafer, with a conductive path making

an electrical connection between a contact pad of the first wafer and a contact pad of the second wafer;

- a cutting step in which the two wafers so connected are cut into smaller electrical entities.

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6. An electrical device that is electrically and mechanically connectable to another electrical device, the electrical device having a face equipped with contact pads, characterised in that the electrical device comprises a connection layer applied to the said face, the connection layer having an adhesive property and comprising a conductive path formed by an opening in the connection layer that extends throughout the connection layer and that has been filled with conductive material.

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7. An electrical assembly comprising a first electrical device and a second electrical device, the first device and the second device being electrically connected to each other by means of a connection layer composed of a substance with adhesive properties, the assembly being characterised in that the connection layer comprises a conductive path formed by an opening that extends through the connection layer and that has been filled with a conductive material.

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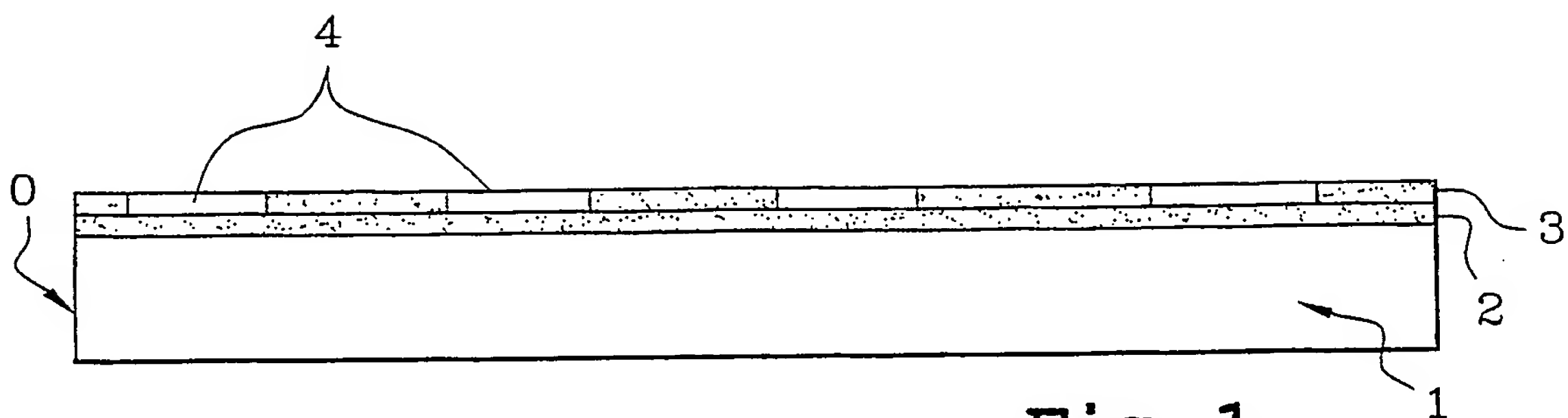


Fig. 1

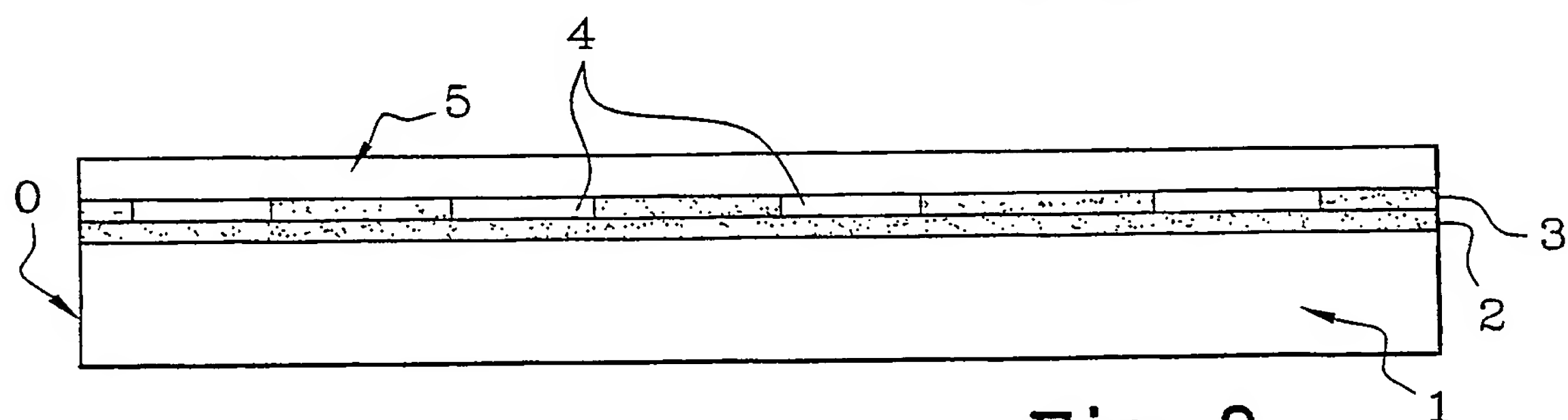


Fig. 2

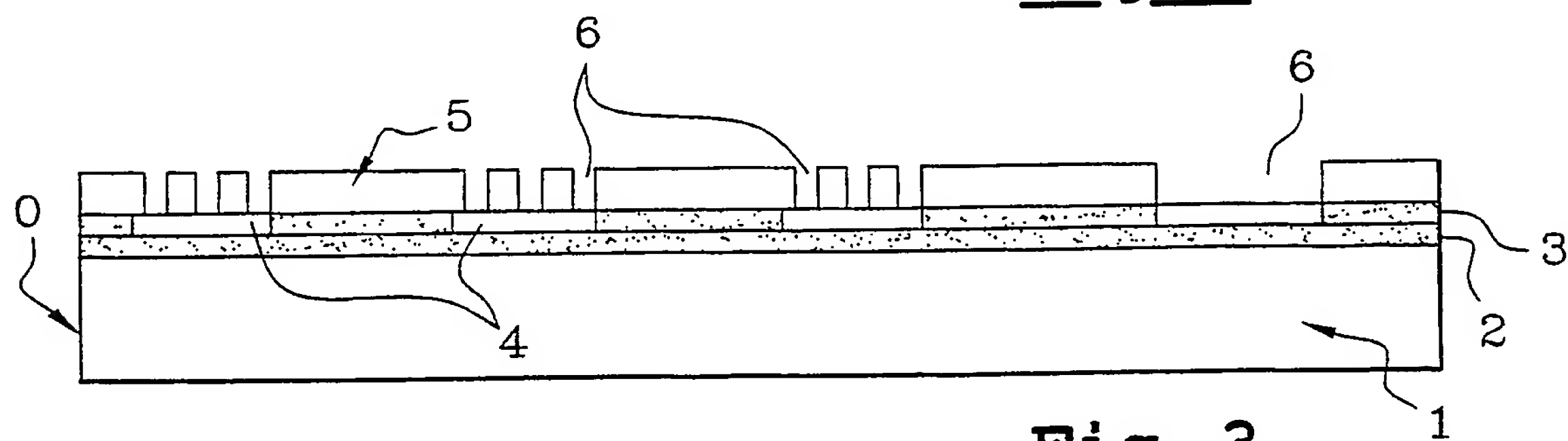


Fig. 3

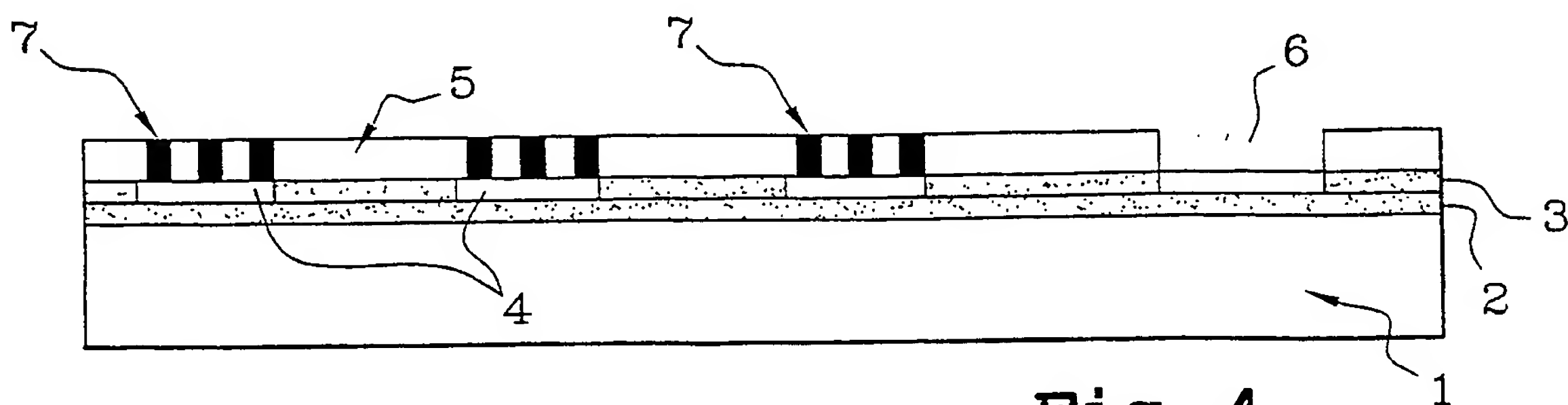


Fig. 4

Fig. 5

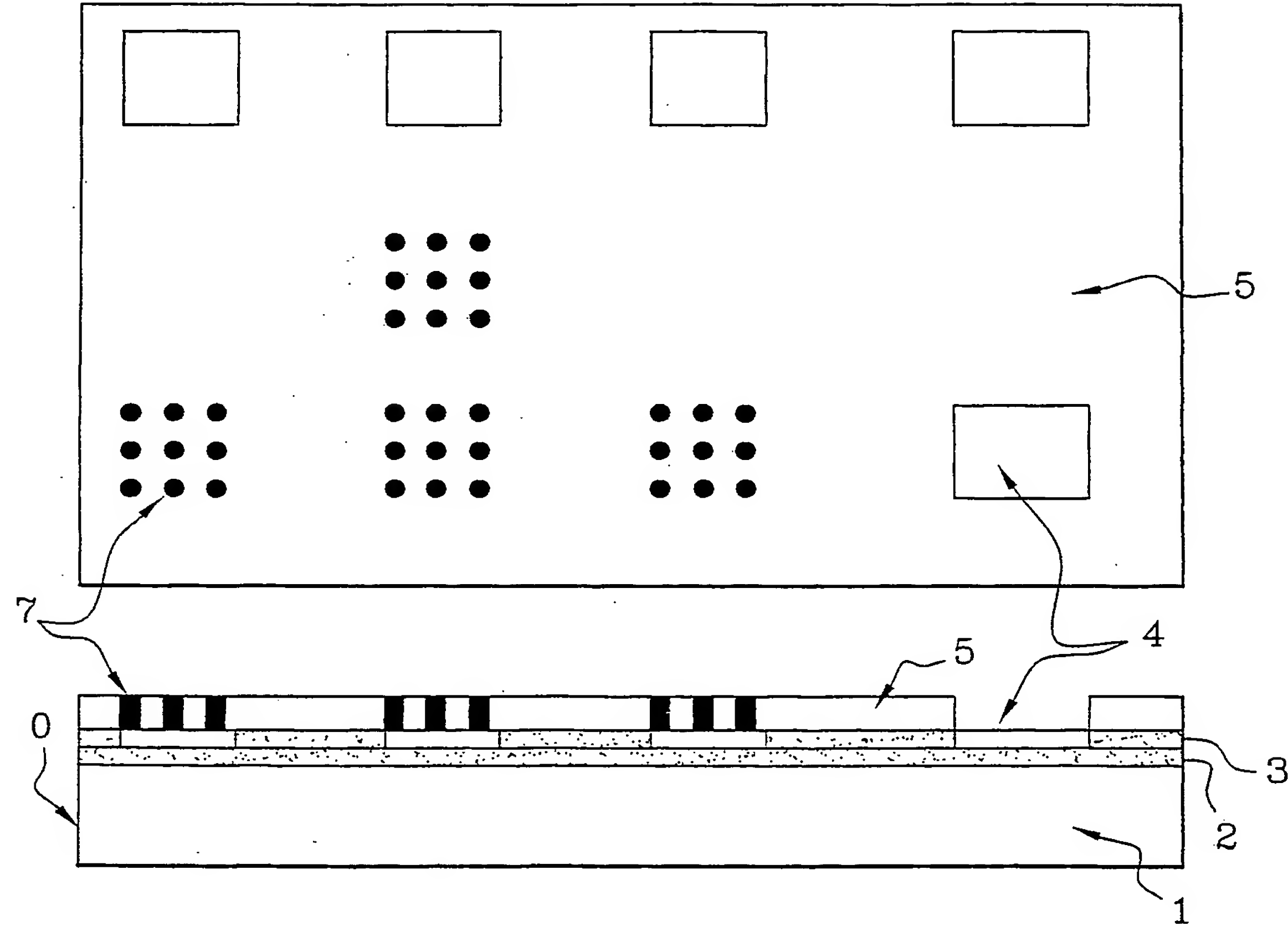


Fig. 6

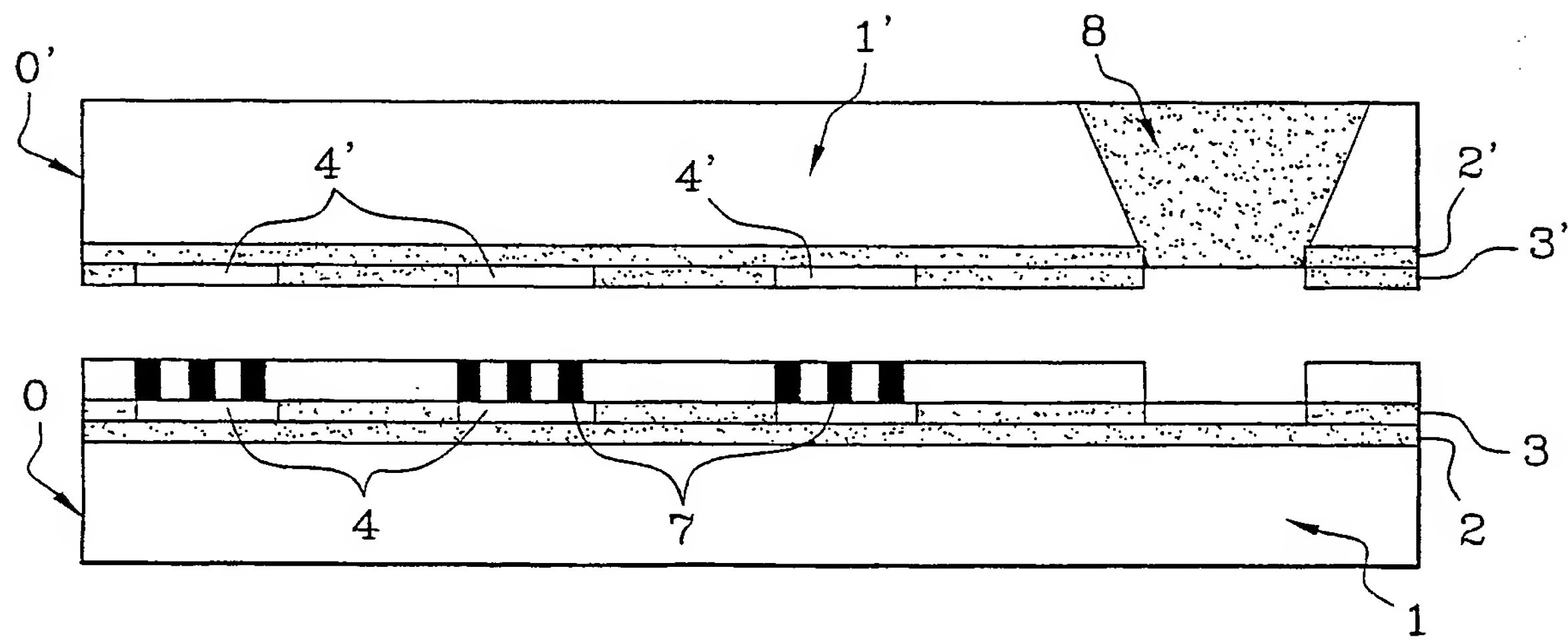
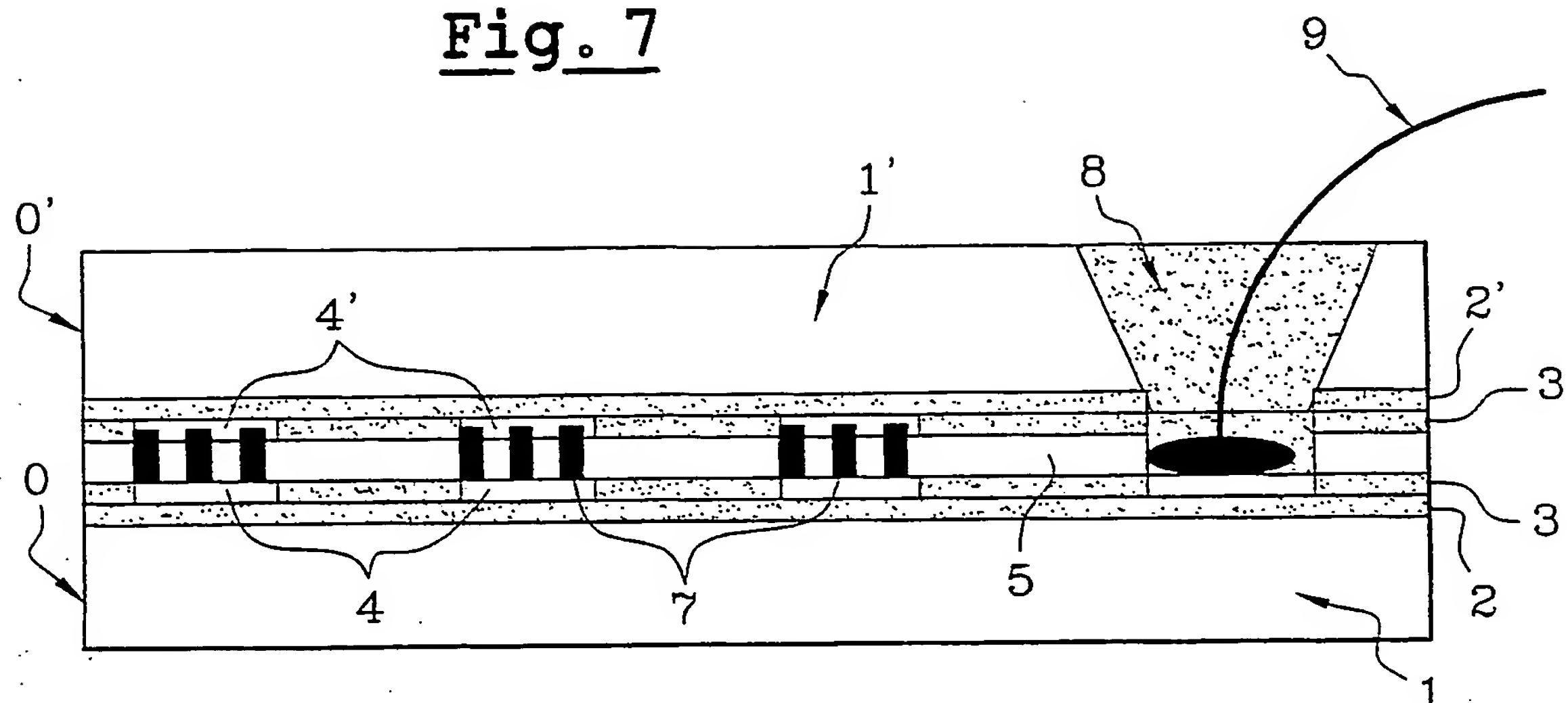
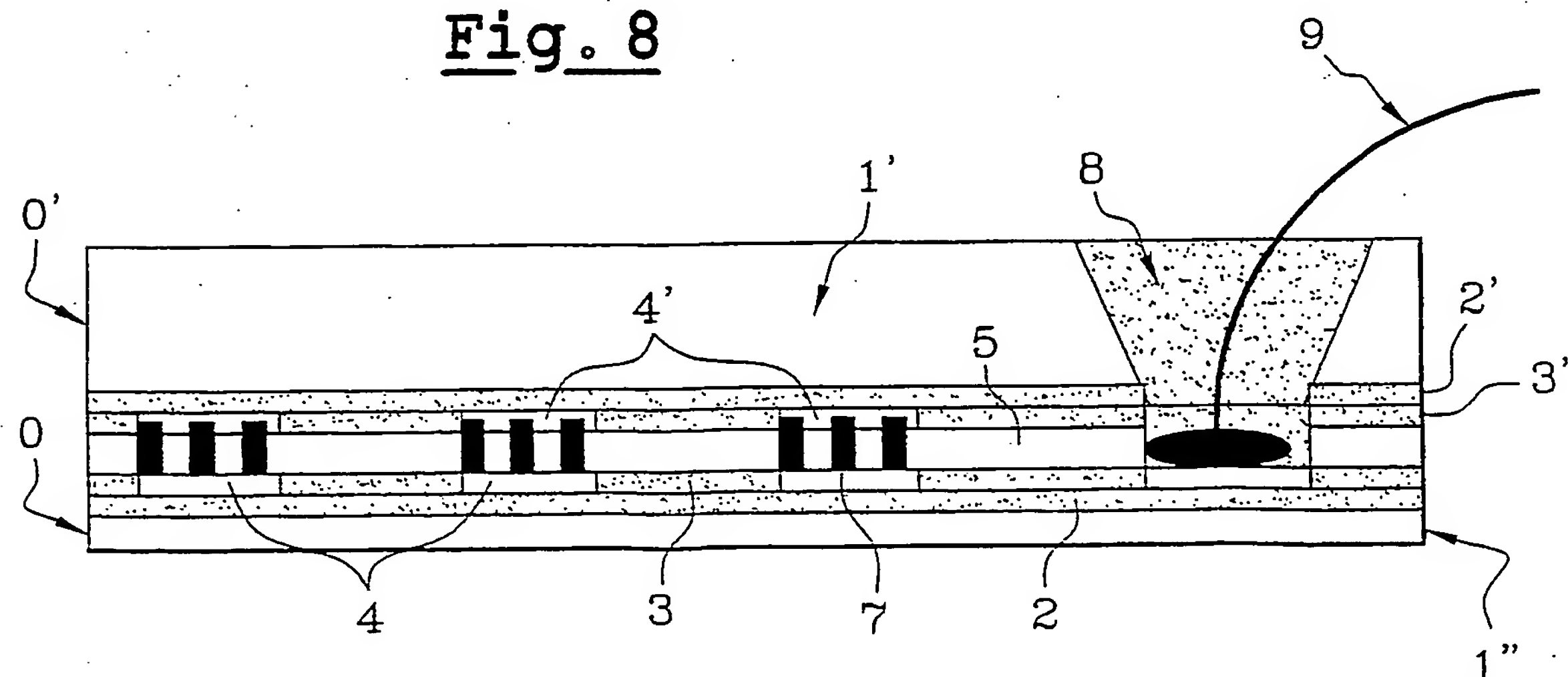


Fig. 7Fig. 8

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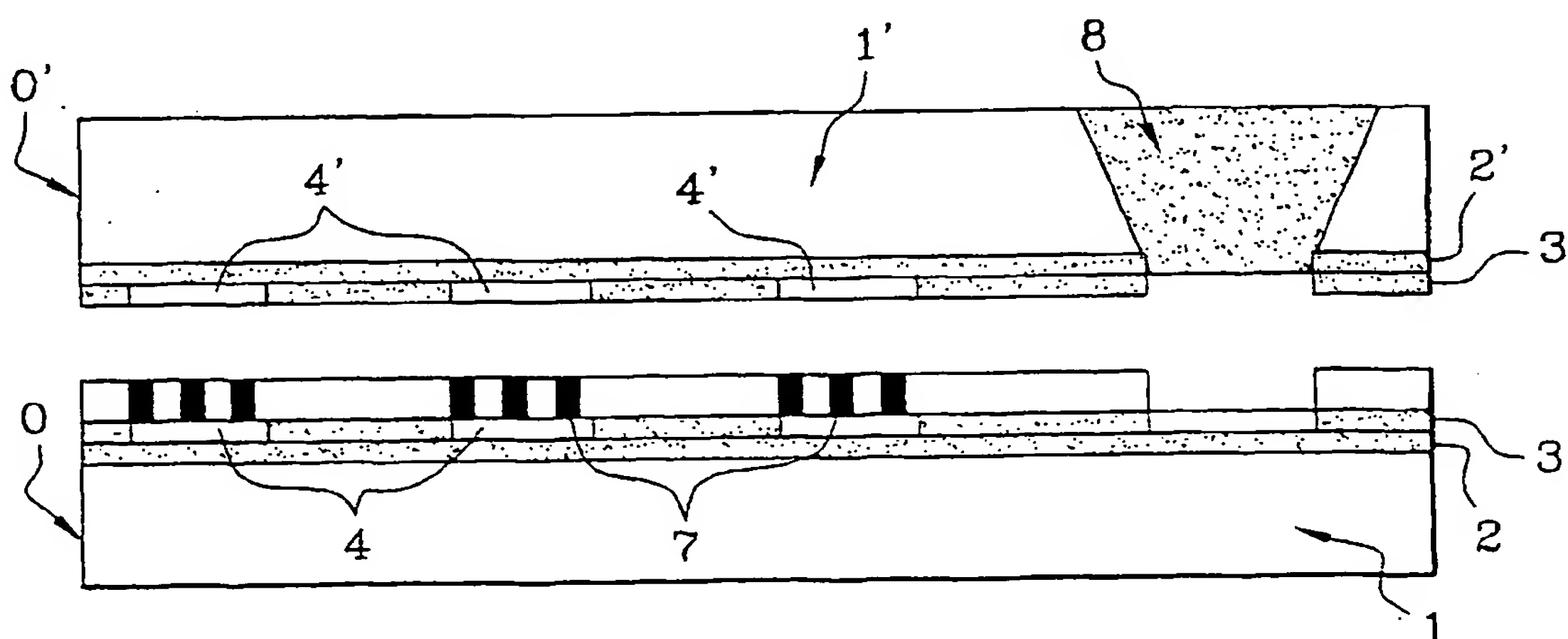
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Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

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C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 5 747 101 A (BOOTH RICHARD B ET AL) 5 May 1998 (1998-05-05) figures 1-4,14	1-7
X	DE 198 00 566 A (SIEMENS AG) 15 July 1999 (1999-07-15) the whole document	1-7
A	US 6 256 874 B1 (DATTA SASWATI ET AL) 10 July 2001 (2001-07-10) figure 1	3



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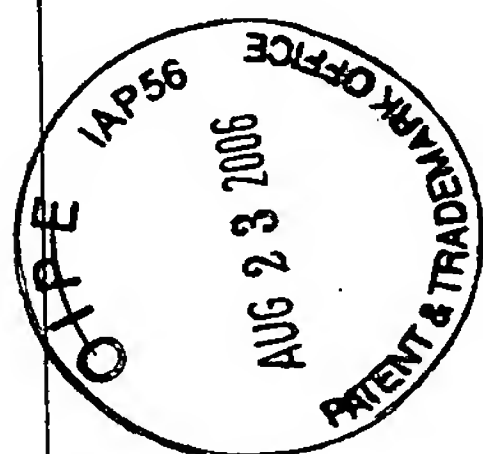
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